

*PATENT* 03371-P0005A LHR

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE)

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Applicants	Lynn David Bollinger, et al.		
Serial No. 09/693,117	Filing Date: October 20, 2000		
Title of Application:	Method for Rapid Thermal Processing of Substrates		
Confirmation No.	Group Art Unit: 2812		
Examiner	Mary Wilezewski		

Assistant Commissioner for Patents Washington, DC 20231

## **Information Disclosure Statement by Applicants**

Dear Sir:

As a means of complying with the duty of disclosure set forth in 37 CFR §1.56, Applicants list the following references.

U.S. Patent Documents						
Exam. Initials	Class/ Subclass.	Document No.	Date	Name		
MW,	357/65	4,783,695	11/08/88	Eichelberger et al.		
mw	437/173	5,302,547	04/12/94	Wojnarowski et al.		
mu	427/96	5,314,709	05/24/94	Doany et al.		
mw	216/65	5,830,376	11/03/98	Bohlke <i>et al.</i>		

<u>Mailing Certificate</u>: I hereby certify that this correspondence is today being deposited with the U.S. Postal Service as *First Class Mail* in an envelope addressed to: Commissioner of Patents and Trademarks; Washington, DC 20231.

February 14, 2003

Caroline Gahagan